## 技术及应用

反熔丝型现场可编程门阵列单粒子锁定实验研究

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摘要 利用单粒子效应脉冲激光和铜源模拟试验系统,对反熔丝型A42MX36现场可编程门阵列进行了单粒 子锁定敏感性评估试验。脉冲激光试验确定了单粒子锁定脉冲激光阈值能量及其等效重离子LET、锁定电流等敏 本 文 信 息 感参数:锎源模拟试验确定了单粒子锁定截面。对试验中出现的由单粒子绝缘击穿和单粒子伪锁定引起的电流 跃变现象进行了讨论和分析。

A42MX36现场可编程门阵列;电流跃变;单粒子绝缘击穿;单粒子伪锁定 关键词 分类号

## Experimental Study on Single Event Latchup of Anti fuse Field Programmable Gate Array

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Abstract Single event latchup sensitivity evaluation tests of anti fuse A42MX36 field programmable gate array were performed using pulsed ||. 252 Cf source single event effect simulation system. Th . aser and e sensitivity parameters such as pulsed laser threshold energy as well as its equivalent heavy ion LET and latchup current of device were de termined in pulsed laser test. The latchup cross section was obtained 252 Cf source test. The current jump phenomena induced by s in ingle event dielectric rupture (SEDR) and pseudo single event latchup (pSEL) in test was also discussed and analyzed.

Key words A42MX36 field programmable gate array current jump sin gle event dielectric rupture pseudo single event latchup

DOI

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